

Japan TC Chapter FPD Metrology Global Technical Committee

Liaison Report

July 2019

V1.0

Meeting Information

- Last Meeting
 - May 31, 2019 at Japan Spring 2019 Meetings
 - Jointly held with FPD Materials & Components
 - SEMI Japan, Tokyo
- Next Meeting
 - November, 2019 at Japan Fall 2019 Meetings
 - Date to be decided
 - SEMI Japan, Tokyo

<http://www1.semi.org/en/standards-events>

Leadership

- Committee Co-chairs
 - Ryoichi Watanabe / Japan Display
 - Akira Kawaguchi / Otsuka Electronics

Current Committee Structure

FPD Metrology Japan TC Chapter

C: Ryoichi Watanabe / Japan Display

C: Akira Kawaguchi / Otsuka Electronics

C: TBA

Committee Activities

- Ballot: None
- New Activities: None
- Five Year Review: None
- SNARF Abolished: None

Thank you!

For more information, please contact:
Chie Yanagisawa, SEMI Japan
cyanagisawa@semi.org